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In The United States Patent and Trademark Office

Appn. Number: 10/725,162

Appn Filed: 2003, December 01

Applicant: Keith Cangiarella

Title: Waste Glass Substrate

Examiner/GAU: Judith A. Nelson/3644

July 30, 2004

Amendment A

Mail Stop Non-Fee Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Madam,

In response to the Office Action Mailed 2004, April 06, please amend the above application as follows: